

<b>Notice of References Cited</b>	Application/Control No. 10/777,012	Applicant(s)/Patent Under Reexamination FOOTE ET AL.	
	Examiner Steven J. Fulk	Art Unit 2891	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,902,640	02-1990	Sachitano et al.	438/202
*	B	US-6,441,441	08-2002	Suda, Kakutaro	257/370
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	S. Wolf, "Silicon Processing for the VLSI Era: The Submicron MOSFET," 1995, Volume 3, pp. 641-642.
	V	
	W	
	X	

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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